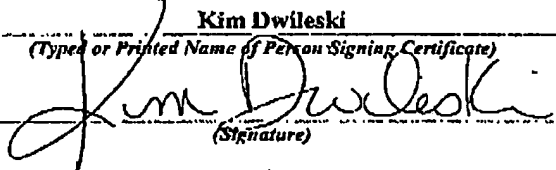


JUN-21-05 TUE 10:29 AM

RECEIVED
CENTRAL FAX CENTER FAX NO.

P. 01

JUN 21 2005

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8) Applicant(s): Grant et al.			Docket No. BUR920040052US1	
Application No. 10/710,700	Filing Date 7/29/2004	Examiner Malsawma, Lalrinfamkim Hmar	Group Art Unit 2823	
Invention: MODIFICATION OF ELECTRICAL PROPERTIES FOR SEMICONDUCTOR WAFERS				
<p>I hereby certify that this _____ Restriction Election (2 pages) _____ (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9306)</p> <p>on <u>6/21/2005</u> (Date)</p> <p style="text-align: right;">Kim Dwileski (Typed or Printed Name of Person Signing Certificate)  (Signature)</p> <p style="text-align: center;">Note: Each paper must have its own certificate of mailing.</p>				

RECEIVED
CENTRAL FAX CENTER
JUN 21 2005

DOCKET NO.: BUR920040052US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICEApplicant(s): Grant *et al.*

Examiner: Malsawma, Lalrinfamkim Hmar

Serial No.: 10/710,700

Art Unit: 2823

Filed: 7/29/2004

For: **MODIFICATION OF ELECTRICAL PROPERTIES FOR SEMICONDUCTOR
WAFERS**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESTRICTION ELECTION

In response to the Restriction Requirement dated May 25, 2005, Applicants hereby provisionally elect Group I, claims 1-22, drawn to a method of fabricating semiconductor wafers, classified in Class 438, subclass 455. This election is made with traverse, and Applicants hereby reserve the right to file a divisional application in connection with unselected claims 23-29, drawn to an electrical structure.

With regard to the Restriction Requirement, Applicants respectfully submit that the subject matter of all claims 1-29 is sufficiently related that a thorough search for the subject matter of any one group of claims would encompass a search for the subject matter of the remaining claims. Thus, Applicants respectfully submit that the search and the examination of the entire application could be made without serious burden. See MPEP § 803, in which it is stated that "if the search and examination of the entire application can be made without serious burden, the Examiner must examine it on the merits." Applicants respectfully submit that this policy

10/710,700

1

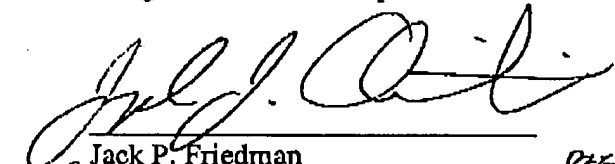
should apply in the present application in order to avoid unnecessary delay and expense to Applicants and duplicative examination by the Patent Office.

Should the Examiner require or request anything further from Applicants prior to examination, the Examiner is requested to contact Applicants' undersigned representative at the telephone number below. Otherwise, Applicants request early and favorable examination on the merits. The Director is hereby authorized to charge and/or credit Deposit Account No. 09-0456.

Date:

6/21/05

Schmeiser, Olsen & Watts
3 Lear Jet Lane, Suite 201
Latham, New York 12110
(518) 220-1850


FOR Jack P. Friedman
Registration No. 44,688

Reg. No.
51,560